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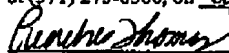
Docket No. 740756-2709

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Koichiro TANAKA ) Confirmation No. 9528  
Application No. 10/769,820 ) Examiner: Samuel Heinrich  
Filed: February 3, 2004 ) Group Art Unit: 1725  
For: LASER IRRADIATION STAGE, LASER )  
IRRADIATION OPTICAL SYSTEM, LASER ) Date: April 24, 2007  
IRRADIATION APPARATUS, LASER )  
IRRADIATION METHOD, AND METHOD )  
OF MANUFACTURING A )  
SEMICONDUCTOR DEVICE )

AMENDMENT AFTER FINAL

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facsimile transmitted to the USPTO  
at (571) 273-8300, on April 24, 2007  
  
Peaches Thomas

Sir:

In response to the Office Action mailed January 24, 2007, please amend the  
above-identified patent application as follows.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 8 of this paper.